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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Hidemasa KAI et al.**

Art Unit: **1792**

Application Number: **10/626,675**

Examiner: **Ram N. Kackar**

Filed: **July 25, 2003**

Confirmation Number: **1831**

For: **EPITAXIAL WAFER PRODUCTION APPARATUS AND SUSCEPTOR STRUCTURE**

Attorney Docket Number: **030901**
Customer Number: **38834**

AMENDMENT UNDER 37 C.F.R. §1.111

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

April 23, 2009

Sir:

This paper is filed in response to the Office Action dated January 26, 2009.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper.